

Notice of References Cited	Application/Control No. 10/526,009		Applicant(s)/Patent Under Reexamination FUJII ET AL.	
	Examiner Abul Kalam		Art Unit 2814	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0180898	12-2002	Yoo et al.	349/43
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	W. S. Wong, S. Ready, R. Matusiak, S. D. White, J.-P. Lu, J. Ho and R.A. Street, "Amorphous silicon thin-film transistors and array fabricated by jet printing, 28 Jan. 2002, American Institute of Physics, APPLIED PHYSICS LETTERS, Vol. 80, No. 4, pg. 610-612.
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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